

Supplemental INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	ATTY DOCKET NO.	SERIAL NO.
	CS 174	10/039,284
	Richard A. Blanchard et al.	
FILING	GROUP	
12/31/01	2811	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PC	1.	10/039,241		Blanchard			12/31/2001
PC	2.	10/038,845		Blanchard			12/31/2001
PC	3.	09/970,758		Blanchard et al.			10/4/2001
PC	4.	2001/0053568A1	12/20/2001	Deboy et al.	438	138	
PC	5.	2001/0036704A1	11/1/2001	Huetting et al.	438	270	
PC	6.	2001/0026977A1	10/4/2001	Hattori et al.	438	268	
PC	7.	5,216,275	6/1/93	Cheo	257	493	
PC	8.	5,108,783	4/28/92	Tanigawa et al.	437	63	
PC	9.	4,893,160	1/9/90	Blanchard	357	23.4	
PC	10.	4,711,017	12/8/87	Lammert	437	20	

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

PC	1.	Xing Bi Chen et al., "A Novel High-Voltage Sustaining Structure with Buried Oppositely Doped Regions," <i>IEEE Transactions on Electron Devices</i> , Vol. 47, No. 6, June 2000, pp. 1280-1285.
PC	2.	N. Cezac et al., "A New Generation of Power Unipolar Devices: the Concept of the Floating Islands MOS Transistor (FLIMOST)," <i>Proceedings of the 12th International Symposium on Power Semiconductor Devices & ICs</i> , Toulouse, France, May 22-25, 2000, pp. 69-72.

EXAMINER

PHAT X. CAO

DATE CONSIDERED

3/11/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PC	11.	4,569,701	2/11/86	Oh	148	188	
R	12.	4,419,150	12/6/83	Soclof	148	187	
R	13.	4,140,558	2/20/79	Murphy et al.	148	175	
R	14.	10/039,068		Blanchard			12/31/01

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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
PC	a.	Ming-Kwang Lee et al., "On the Semi-Insulating Polycrystalline Silicon Resistor," <i>Solid State Electronics</i> , Vol. 27, No. 11, 1984, pp. 995-1001.	

EXAMINER PHAT X. CAO	DATE CONSIDERED 3/11/04
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